

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Tomoharu NAKANO et al.**

Serial Number: **Not yet assigned**  
(§371 of international application No. PCT/JP2004/006027)

Filed: **October 5, 2005**

For: **POLISHING LIQUID FOR CMP PROCESS AND POLISHING  
METHOD**

Attorney Docket Number: **052463**

Customer Number: **38834**

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

October 5, 2005

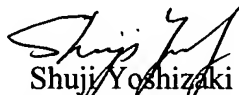
Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08 and cited in the enclosed international search report. Since the documents were cited in the international search report, it is believed that copies of the documents have been transmitted by the International Bureau.

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Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**



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Enclosures: PTO/SB/08 and International Search Report

10/552606

JC09 Rec'd PCT/PTO 15 OCT 2005

Combined Form PTO/SB/08A&B  <b><u>INFORMATION DISCLOSURE</u></b> <b><u>STATEMENT BY APPLICANT</u></b>  <i>(use as many sheets as necessary)</i>				<i>Complete if Known</i>	
				Application Number	New Application
				Confirmation Number	
				Filing Date	October 5, 2005
				First Named Inventor	Tomoharu NAKANO et al.
				Art Unit	
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	052463

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>3</sup> (if known)		
		US			
		US			
		US			
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		US			
		US			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			
	1	JP	2002-184726		06-28-2002	Kabushiki Kaisha Okamoto KKS	
	2	JP	10-172935		06-26-1998	Fujimi, Inc.	
	3	JP	2003-86548		03-20-2003	Hitachi, Ltd.	
	4	JP	2000-280165		10-10-2000	Applied Materials, Inc.	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kind Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov), MPEP 901.04 or in the comment box of this document. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to indicate here if English language Translation is attached.